

ACKNOWLEDGEMENT RECEIPT

Electronic Version 1.1

Stylesheet Version v1.1.1

Title of Invention

COMPOSITION FOR AN ETCHING MASK COMPRISING A
SILICON-CONTAINING MATERIAL

Submission Type : Information Disclosure
Statement

Application Number:

10/789319



EFS ID:

75261

Server Response:

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ISVR1	Submission was successfully submitted - Even if Informational or Warning Messages appear below, please do not resubmit this application
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First Named Applicant: Frank Xu

Attorney Docket Number: P121-63-03

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File Listing:

Doc. Name	File Name	Size (Bytes)	Date Produced (yyyymmdd)
us-ids	P121-63-03_EIDS2-usidst.xml	1011	2005-01-04
us-ids	us-ids.dtd	7763	2005-01-04
us-ids	us-ids.xsl	12026	2005-01-04
package-data	P121-63-03_EIDS2-pkda.xml	1935	2005-01-04
package-data	package-data.dtd	27025	2005-01-04
package-data	us-package-data.xsl	19263	2005-01-04
Total files size		69023	

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